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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

February 12, 2001



ROBERT G. WENDT, SCOTT WIEDEMAN,
JEFFREY S. BRITT and DOUGLAS G. MASON

Serial No. : 09/613,951
Filed : July 11, 2000
For : NOZZLE-BASED, VAPOR-PHASE, PLUME DELIVERY
STRUCTURE FOR USE IN PRODUCTION OF THIN-FILM-
DEPOSITION LAYER

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §§ 1.56, 1.97 and 1.98

Pursuant to applicants' duty of disclosure required under 37 C.F.R. § 1.56, applicants are submitting this information disclosure statement under 37 C.F.R. §§ 1.97 and 1.98 to bring to the attention of the U.S. Patent and Trademark Office the following references. The listing of any reference or the submission of a copy of any reference shall not be deemed as an admission that the listed or submitted reference is prior art for this application.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on February 12, 2001.

Pierre Van Rysselberghe
Date of Signature: February 12, 2001

Respectfully submitted,

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